

Notice of References Cited	Application/Control No. 10/052,411	Applicant(s)/Patent Under Reexamination LEE, JONG HAN	
	Examiner Emmanuel Bayard	Art Unit 2611	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0094043	07-2002	Chu et al.	375/346
*	B	US-6,798,832	09-2004	Nakata et al.	375/233
*	C	US-6,356,586	03-2002	Krishnamoorthy et al.	375/233
*	D	US-6,760,372	07-2004	Zortea et al.	375/232
*	E	US-6,201,832	03-2001	Choi, Byung-Bong	375/233
*	F	US-5,757,855	05-1998	Strolle et al.	375/262
*	G	US-6,038,269	03-2000	Raghavan, Sreen A.	375/340
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.